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## \*BIBDATASHEET\*

CONFIRMATION NO. 4003

Bib Data Sheet

SERIAL NUMBER 10/627,894	FILING DATE 07/24/2003 RULE	CLASS 427	GROUP ART UNIT 1762	ATTORNEY DOCKET NO. AXC 0001 I3 (01-SM5-218 C
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

*MW 7/26/05*  
 This application is a CIP of 10/346,560 01/17/2003 *abd 12/29/03*  
 which is a CIP of 09/952,649 09/14/2001, issued as P.N. 6,913,796  
 which is a CIP of 09/528,835 03/20/2000 PAT 6,576,300  
 and is a CIP of 09/681,332 03/19/2001 PAT 6,558,755

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 11/05/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	VA	DRAWING 0	CLAIMS 26	CLAIMS 3

## ADDRESS

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 45402-2023

## TITLE

Fluorine-free plasma curing process for porous low-k materials

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
RECEIVED 858	No. _____ for following:	<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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		<input type="checkbox"/> Other _____
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